

ENV 9851.1 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Brian M. Burmaster, et al. Serial No. 09/693,418
Filed October 20, 2000
Confirmation No. 1265
For PROCESS FOR THE PRODUCTION OF SULFUR

July 31, 2001



SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

TO THE COMMISSIONER OF PATENTS AND TRADEMARKS, SIR:

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicants submit copies of the references listed on the attached Form PTO/SB/08A for consideration by the Patent and Trademark Office in the above-referenced patent application and to be made of record therein.

One of the enclosed references is a copy of the International Search Report prepared by the European Patent Office in connection with International Application No. PCT/US 00/29022. International Application No. PCT/US 00/29022 is the PCT analog of the subject U.S. application.

This Supplemental Information Disclosure Statement is being submitted pursuant to 37 C.F.R. §1.97(b) in that applicants believe that it is being filed prior to the mailing date of the first Office action on the merits. Accordingly, neither a statement nor fee under 37 C.F.R. §1.97(c) or (d) is required. However, if the mailing date of the first Office action on the

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merits in fact precedes the filing of this Supplemental Information Disclosure Statement, the undersigned, pursuant to 37 C.F.R. §1.97(c) and (e), states that each item of information contained in this Supplemental Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Supplemental Information Disclosure Statement.

Respectfully submitted,

Vincent M. Keil, Reg. No. 36,838 SENNIGER, POWERS, LEAVITT & ROEDEL One Metropolitan Square, 16th Floor

an Clements

St. Louis, Missouri 63102

(314) 231-5400

CERTIFICATE OF MAILING

I certify that this SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT, attached Form PTO/SB/08A and reference copies are being deposited with the United States Post Office as First Class Mail, postage prepaid in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the 31st day of July, 2001.

M. Susan Clements

VMK/msc

*Enclosure/Attachment